

Fabrication of Basic Devices Out of Cleanroom

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NNIN Facility utilized: Nanofabrication Center

Objective : Introducing equipment and techniques for fabrication of basic devices without having access to a cleanroom.

Equipment

- ◆ Spinner in the box
- ◆ Hot plate
- ◆ Microscope
- ◆ Oven



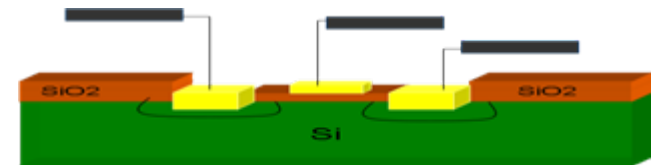
Sample devices that can be fabricated



Plated resistor



Solar Cell



MOSFET